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APPLICANTS

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This application is a DIV of 09/791,853 02/26/2001 PAT 6,756,614

** FOREIGN APPLICATIONS ***** *TN*

JAPAN 2001-19570 01/29/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 9	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>TN</i>	Initials		

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TITLE

Thin film semiconductor device, polycrystalline semiconductor thin film production process and production apparatus

☐ All Fees☐ 1.16 Fees (Filing)